

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. .... 10/071,425  
Priority Filing Date ..... February 8, 2002  
 Inventor ..... Terry L. Gilton et al.  
 Assignee ..... Micron Technology, Inc.  
Priority Group Art Unit ..... 2813  
Priority Examiner ..... Thanhha S. Pham  
 Attorney's Docket No. .... MI22-2440  
 Customer No. .... 021567  
 Title: Semiconductor Processing Method Using Photoresist and an  
 Antireflective Coating

**PRELIMINARY AMENDMENT**

To: Mail Stop Patent Application  
 Commissioner for Patents  
 P. O. Box 1450  
 Alexandria, VA 22313-1450

**VIA EXPRESS MAIL**

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Please enter the following amendments prior to examining the above-identified application.

**AMENDMENTS**